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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Habib Vafi et al.

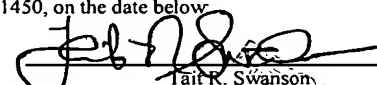
Serial No.: 10/063,432

Filed: April 23, 2002

For: Method for Assembling Tiled Detectors
for Ionizing Radiation Based Image
Detection

§
§ Group Art Unit: 3729
§
§
§ Examiner: Trinh, Minh N.
§
§
§ Atty. Docket: 120358-1/YOD/SWA
(GEMS:0186)

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CERTIFICATE OF MAILING 37 C.F.R. 1.8	
I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Mail Stop L&R, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:	
January 3, 2006	
Date	Tait R. Swanson

Dear Sir:

A Property Rights Declaration under 35 U.S.C. § 25 in Response to a "Notice" dated November 22, 2005, and a copy of the Notice dated November 22, 2005, is enclosed herewith.

Respectfully submitted,

Date: January 3, 2006


Tait R. Swanson
Reg. No. 48,226
FLETCHER YODER
P.O. Box 692289
Houston, TX 77269-2289
(281) 970-4545

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Habib Vafi et al.

Serial No.: 10/063,432

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Group Art Unit: 3729

Examiner: Trinh, Minh N.

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Ok
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January 3, 2006	<i>[Signature]</i>
Date	Tait R. Swanson

PROPERTY RIGHTS DECLARATION UNDER 35 U.S.C. § 25

We – Habib Vafi, David C. Neumann, Scott W. Petrick, and Jeffrey A. Kautzer -
declare that:

(1) We made and conceived the invention described and claimed in patent application serial number 10/063,432, filed in the United States of America on April 23, 2002, and entitled: Method for Assembling Tiled Detectors for Ionizing Radiation Based Image Detection;

(2) We made and conceived this invention while employed by General Electric Company, a New York Corporation;

(3) That this invention is related to the work we are employed to perform and was made within the scope of our employment duties;

(4) We made this invention during working hours and with the use of facilities, equipment, materials, funds, information and services of General Electric Company; and

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(5) To the best of our knowledge and belief:

(a) The invention or discovery was not made or conceived in the course of, or in connection with, or under the terms of any contract, subcontract or arrangement entered into with or for the benefit of the United States Atomic Energy Commission or its successors: Energy Research and Development Administration or the Department of Energy; and

(b) The invention was not made (conceived or first actually reduced to practice) under nor is there any relationship of the invention to the performance of any work under any contract of the National Aeronautics and Space Administration.

The undersigned inventors declare further that all statements made herein of their own knowledge are true and that all statements made on information and belief are believed to be true and further that these statements are made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

Full name of first joint inventor: **Habib Vafi**

Inventor's signature

Habib Vafi

Date: 01, 03, 2006

Residence: Brookfield, WI 53045

Citizenship: USA

Post Office Address: 19260 Baythorn Way, Brookfield, WI - 53045 USA

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Property Rights Declaration
Page 3

Full name of second joint inventor: **David C. Neumann**

Inventor's signature David C. Neumann

Date: Dec. 14, 2005

Residence: Milwaukee, WI

Citizenship: USA

Post Office Address: 3731 N. 85 St., Milwaukee, WI - 53222 USA

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Property Rights Declaration
Page 4

Full name of third joint inventor: **Scott W. Petrick**

Inventor's signature Scott Wm. Petrick

Date: Jan 3, 2006

Residence: Sussex, WI

Citizenship: USA

Post Office Address: N77 W24677 Century Ct., Sussex, WI 53089 USA

Full name of fourth joint inventor: **Jeffrey A. Kautzer**

Inventor's signature Jeffrey A. Kautzer

Date: 12-20-2005

Residence: Pewaukee, WI

Citizenship: USA

Post Office Address: W283 N3920 Yorkshire Trace, Pewaukee, WI - 53072 USA



120358-1 YOD/SUA CD
UNITED STATES DEPARTMENT OF COMMERCE
Patent and Trademark Office

Address: COMMISSIONER OF PATENTS AND TRADEMARKS
Washington, D.C. 20231

SERIAL NUMBER	FILING DATE	FIRST NAMED APPLICANT	ATTORNEY DOCKET NO.
10/063,432	04/23/2002	Habib Vafi	GEMS186/YOD

FLETCHER, YODER & VAN SOMEREN
P. O. BOX 692289
HOUSTON, TX 77269-2289

EXAMINER
ART UNIT 1 & TRADEMARK OFFICE
MAILED

DATE MAILED: NOV 22 2005

This application has been reported by the Examiner as in condition for allowance.

LICENSING & REVIEW

The subject matter of this application appears to be "useful in the production or utilization of special nuclear material or atomic energy" as recited in Section 152 of the Atomic Energy Act of 1954 (Public Law 703, 83rd Congress, 2nd Session, AS AMENDED September 6, 1961 by Public Law 87-206, 87th Congress, 42 U.S.C. 2182). Accordingly, it would appear that no patent can issue on this application until there is filed by the applicant(s), a statement under oath, or in lieu thereof, a declaration (as provided by 35 U.S.C. 25), setting forth the full facts surrounding the making and conception of the invention and whether it was made or conceived in the course of or under any contract, subcontract, or arrangement entered into WITH OR FOR THE BENEFIT OF the Atomic Energy Commission, the Energy Research and Development Administration (Public Law 93-438, 93rd Congress, 42 U.S.C. 5801) or the Department of Energy (Public Law 95-91, 95th Congress, 42 U.S.C. 7101) as required in said section of the Atomic Energy Act.

In the event 35 U.S.C. 202 has been made applicable by express provision in any contract, grant or cooperative agreement with the Department of Energy which may have a relationship to the subject matter of this application, applicant may file a statement under oath, or in lieu thereof a declaration (as provided by 35 U.S.C. 25), to the effect that 35 U.S.C. 202 is applicable, as an alternative to the statement required above. A false statement regarding this applicability of 35 U.S.C. 202 shall be considered a false representation of a material fact which may result in a request for transfer of title to the patent, which issues on this application, to the Department of Energy pursuant to Section 152 of the Atomic Energy Act.

It is considered appropriate for a statement to be filed at this time without formal requirement and this letter has been sent in order to give applicant(s) an opportunity to do so.

Should it be necessary to consider the need for a formal requirement for the statement, no provision is found in the Atomic Energy Act for extension of the time limit of 30 days after requirement is made, set by Section 152.

This application will be reached for processing in about FORTY-FIVE DAYS. Final disposition thereof will be expedited if an appropriate statement is filed during this period.

Respectfully,


SPECIAL LAWS
ADMINISTRATION GROUP

DOCKETED
FOR 1/6/2006
BY 1/10
CHECK'D BY KH 12/2

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NOV 29 2005

Fletcher Yoder

PLEASE DIRECT ALL COMMUNICATIONS RELATING TO THIS MATTER TO THE ATTENTION OF LICENSING AND REVIEW.